



Niesen 540

CEM S.A. NEUCHÂTEL
CONSTRUCTIONS ÉLECTRIQUES ET MÉCANIQUES

R_1 200 Ω 1/2w.	R_{11} 0,1 M Ω 1/2w.	C_1 200pF mica	C_{11} accordé mica	C_{21} 150pF pap.	C_{31} 50 μ F 35V.	L_4 accord OC.
R_2 50 k Ω "	R_{12} 1,5 M Ω "	C_2 1000pF pap.	C_{12} " "	C_{22} 10 000pF "	C_{32} 50 μ F "	L_5 " P.O.
R_3 0,2 M Ω "	R_{13} 0,1 M Ω "	C_3 accordé mica	C_{13} ajustable air	C_{23} 200pF "	C_{33} 5000pF 3000V	L_6 " G.O.
R_4 50 k Ω 2w.	R_{14} 1 M Ω "	C_4 " "	C_{14} 1000pF mica	C_{24} 150pF "	T_1 1 ^{re} MF 472 kc/s.	L_7 entretien OC.
R_5 30 k Ω "	R_{15} 50 k Ω "	C_5 " "	C_{15} 50pF "	C_{25} 20000pF "	T_2 2 ^{de} MF 472 kc/s.	L_8 osc. O.C.
R_6 250 Ω 1w.	R_{16} 40 Ω "	C_6 ajustable air	C_{16} 0,1 μ F pap.	C_{26} 150pF "	T_3 Sortie HP	L_9 " P.O.
R_7 50 k Ω 1/2w.	R_{17} 125 Ω 4w.	C_7 accordé mica	C_{17} 0,1 μ F "	C_{27} 50 000pF "	T_4 alimentation	L_{10} " G.O.
R_8 200 k Ω "	R_{18} 50 k Ω 1/2w.	C_8 " "	C_{18} 50000pF "	C_{28} 0,1 μ F "	L_1 choc ant.	L_{11} excitation HP.
R_9 200 k Ω "	P_1 0,5 M Ω	C_9 " "	C_{19} 0,1 μ F "	C_{29} 25 μ F 450V.	L_2 bouchon 472kc/s	
R_{10} 1 M Ω "	P_2 50 k Ω	C_{10} " "	C_{20} 150pF "	C_{30} 32 μ F	L_3 prim. O.C.	